

Form PTO-1449 U.S. Department of Commerce  
(Rev. 8-88) Patent and Trademark Office

Attorney Docket No.: 1201.65872

Serial No.: 09/989,050

INFORMATION DISCLOSURE CITATION  
(Use several sheets if necessary)

Applicant: Bohn et al.

Filing Date: Nov. 20, 2001

Group: 1746



## PATENT DOCUMENTS

Examiner Initial*	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
LV	3,653,989	Apr. 4, 1972	Widmer			
	4,078,945	Mar. 14, 1978	Gonsiorawski			
	4,681,657	Jul. 21, 1987	Hwang et al.			
	5,089,293	Feb. 18, 1992	Bohara et al.			
	5,695,557	Dec. 9, 1997	Yamagata et al.			
	5,868,947	Feb. 9, 1999	Sakaguchi et al.			
	5,873,003	Feb. 16, 1999	Inoue et al.			
	5,895,223	Apr. 20, 1999	Peng et al.			
	5,981,400	Nov. 9, 1999	Lo			
	5,990,605	Nov. 23, 1999	Yoshikawa et al.			
	6,017,811	Jan. 25, 2000	Winton et al.			
LV	6,093,941	Jul. 25, 2000	Russell et al.			

RECEIVED  
APR 03 2003  
GROUP 1700

## FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

LV	D. Dimova-Malinovska, M. Sendova-Vassileva, N. Tzenov and M. Kamenova, "Preparation of Thin Porous Silicon Layers by Stain Etching", <i>Thin Solid Films</i> , 297, 1997, pp. 9-12.

Examiner

LAN VINH

Date Considered

5/7/2003